



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In reapplication of

MICHAEL SHU-HUAN WANG ET AL.

Serial No. 10/718,921 (TI-34402)

Filed November 21, 2003

For: CHEMICAL-MECHANICAL POLISHING APPARATUS AND METHOD TO  
MINIMIZE SLURRY ACCUMULATION AND SCRATCH EXCURSIONS

Art Unit 2399

Examiner SHANTESE L. McDONALD

Customer No. 23494

Mail Stop Amendment  
Commissioner for Patents  
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**CERTIFICATE OF MAILING OR TRANSMISSION UNDER 37 CFR 1.8**

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Jay M. Cantor, Reg. No. 19,906

**AMENDMENT UNDER 37 C.F.R. 1.111**

In response to the Office action dated July 1, 2005, please amend the above-identified application as follows: